

<b>Notice of References Cited</b>	Application/Control No. 10/764,606	Applicant(s)/Patent Under Reexamination SHIMIZU ET AL.	
	Examiner Eric B. Chen	Art Unit 1765	Page 1 of 1

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf et al., Silicon Processing for the VLSI Era, 1986, Lattice Press, Vol. 1, pp. 532-33.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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